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** FOREIGN APPLICATIONS ** JAPAN 2002-315900 10/30/2002 JAPAN 2003-360192 10/21/2003				
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ADDRESS 38834 WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP 1250 CONNECTICUT AVENUE, NW SUITE 700 WASHINGTON, DC 20036				
TITLE Silicon oxycarbide, growth method of silicon oxycarbide layer, semiconductor device and manufacture method for semiconductor device				
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